

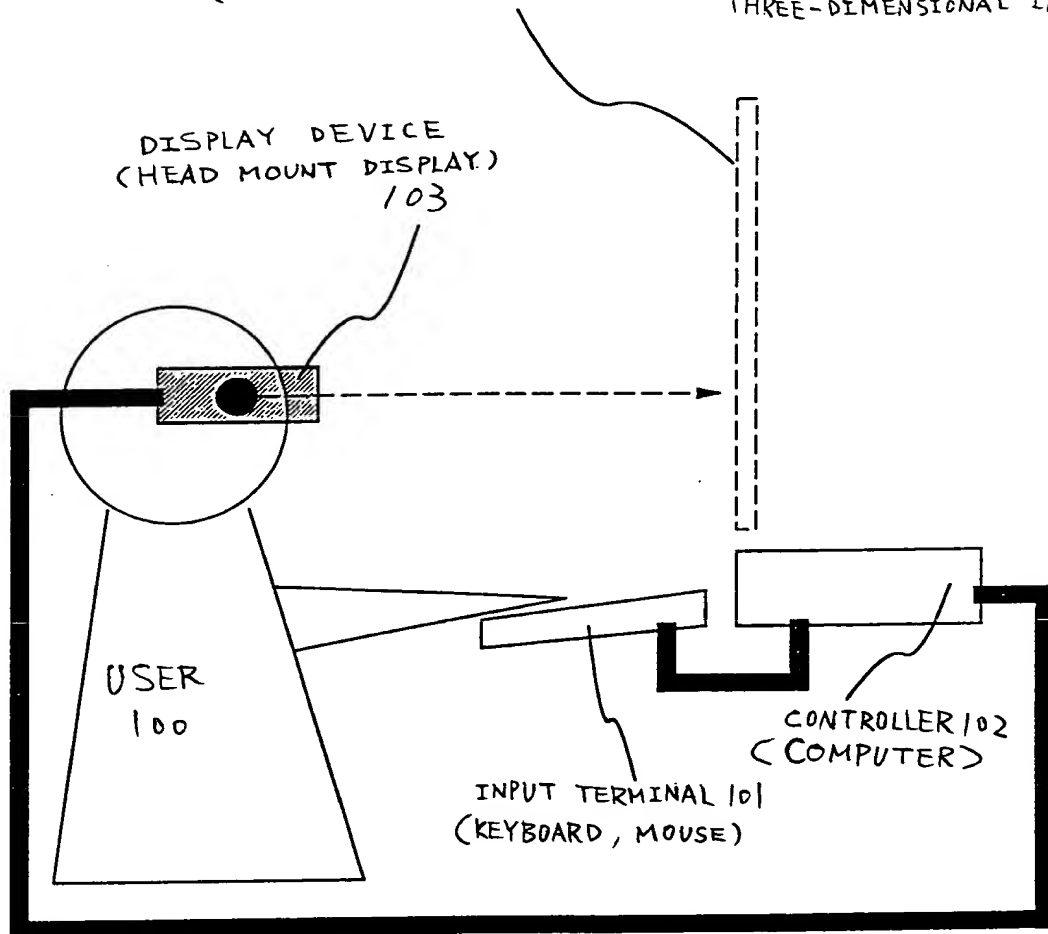
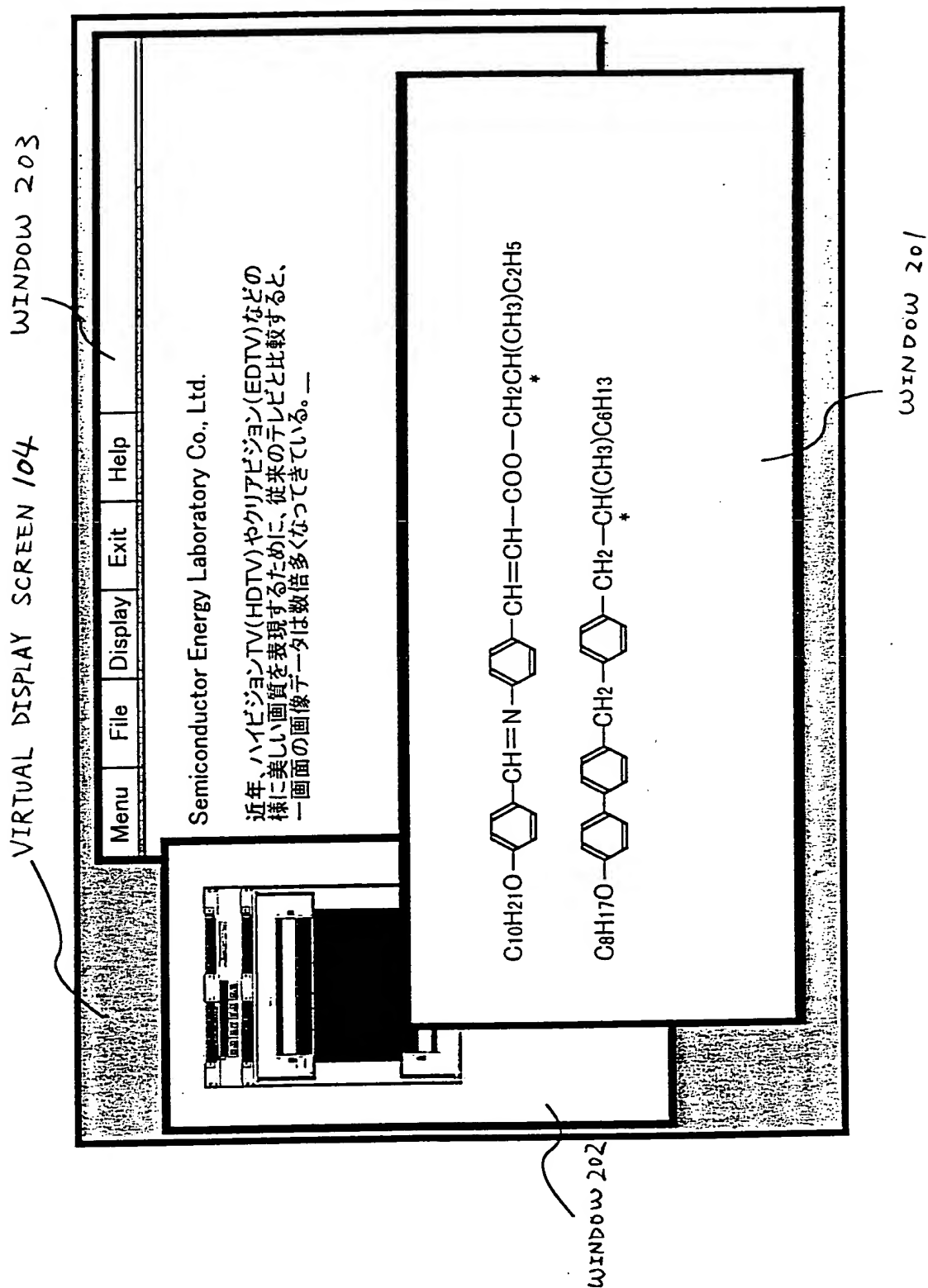
[illegible]

Fig. 1



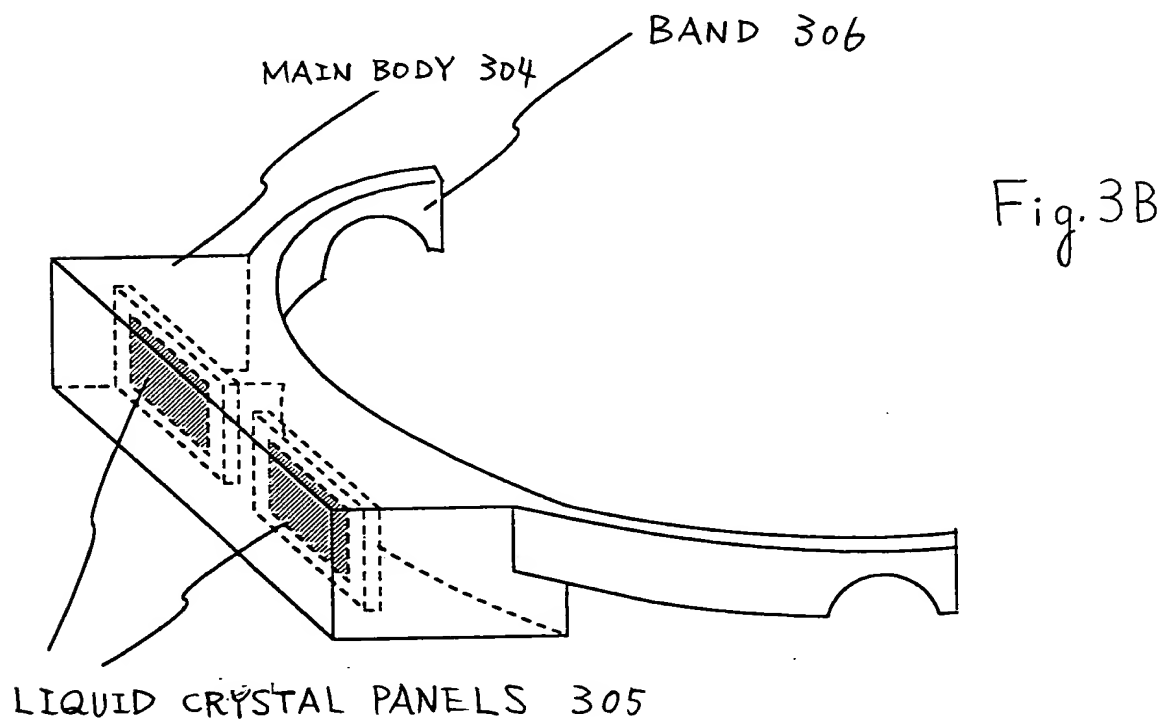
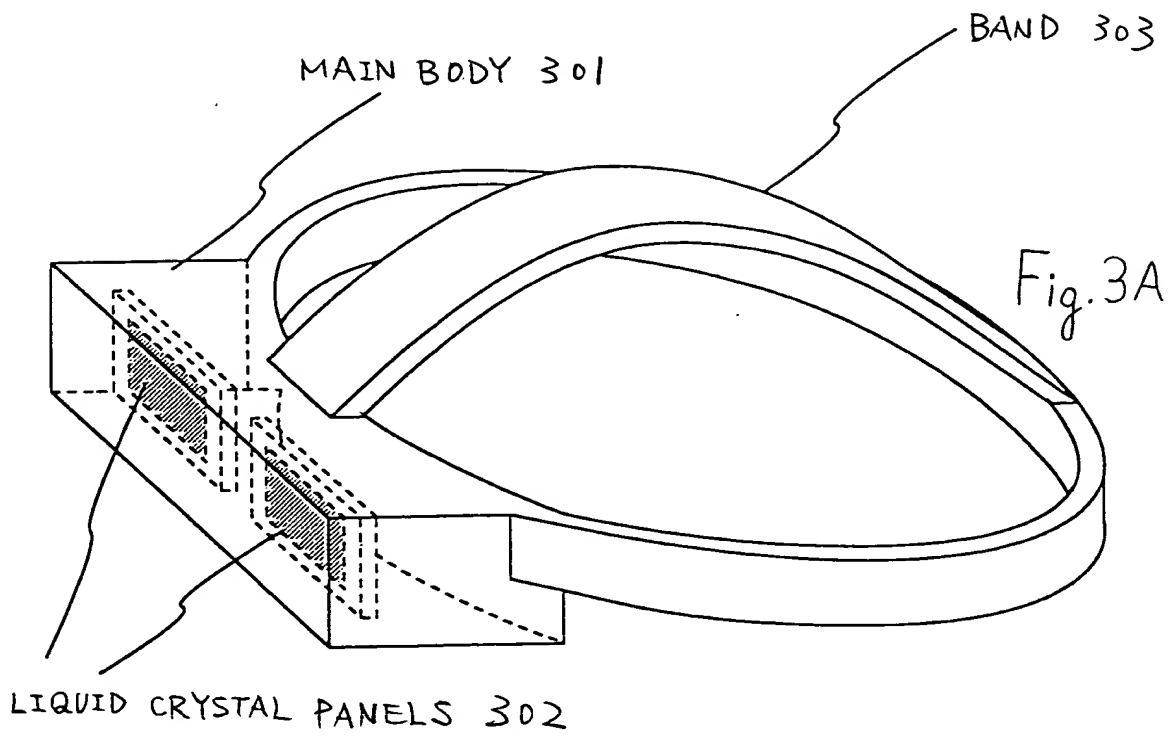
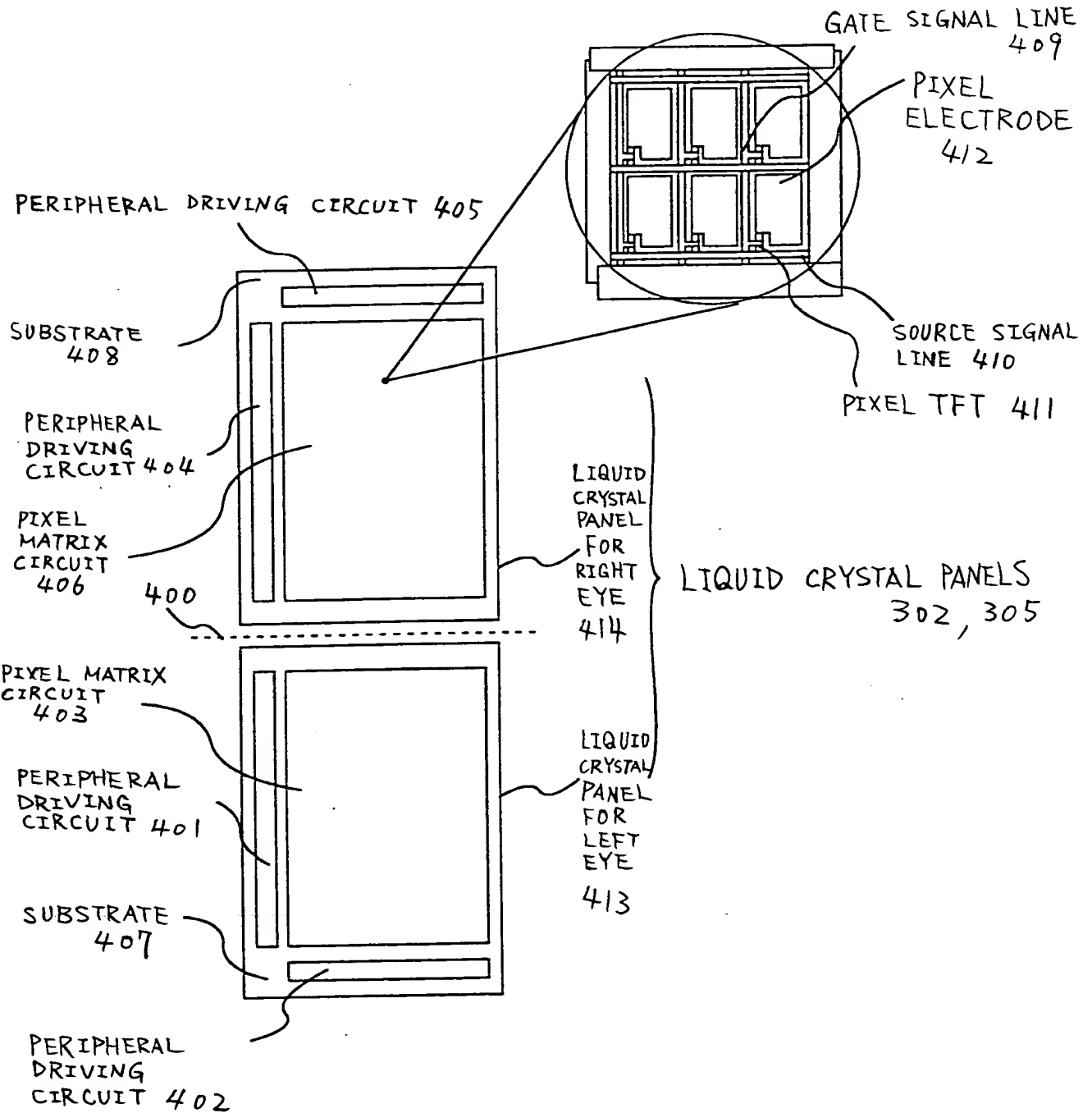
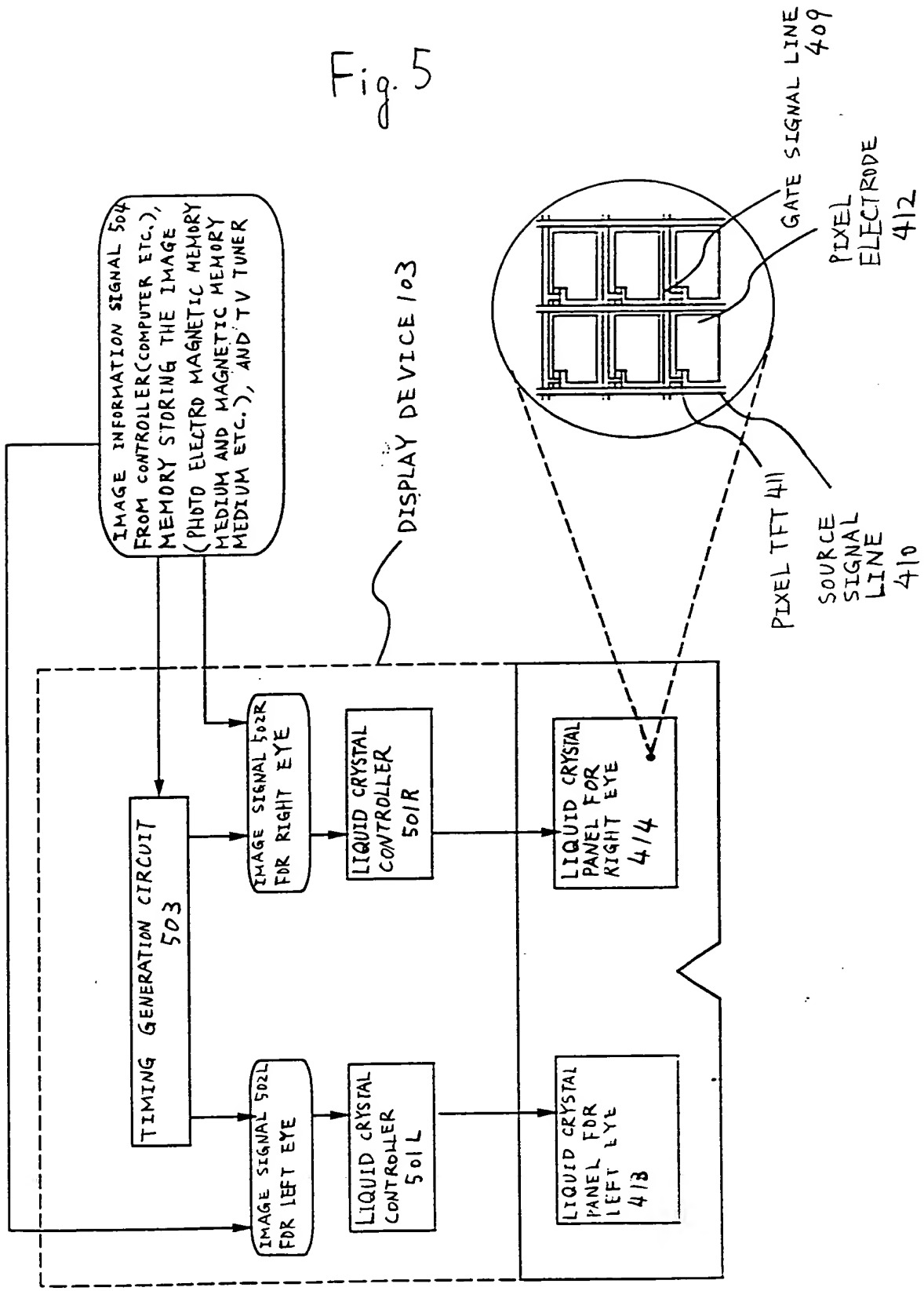


Fig. 4



66220 5055260



VIRTUAL DISPLAY SCREEN 607  
(DISPLAY SCREEN FOR TWO-DIMENSIONAL OR  
THREE-DIMENSIONAL IMAGES)

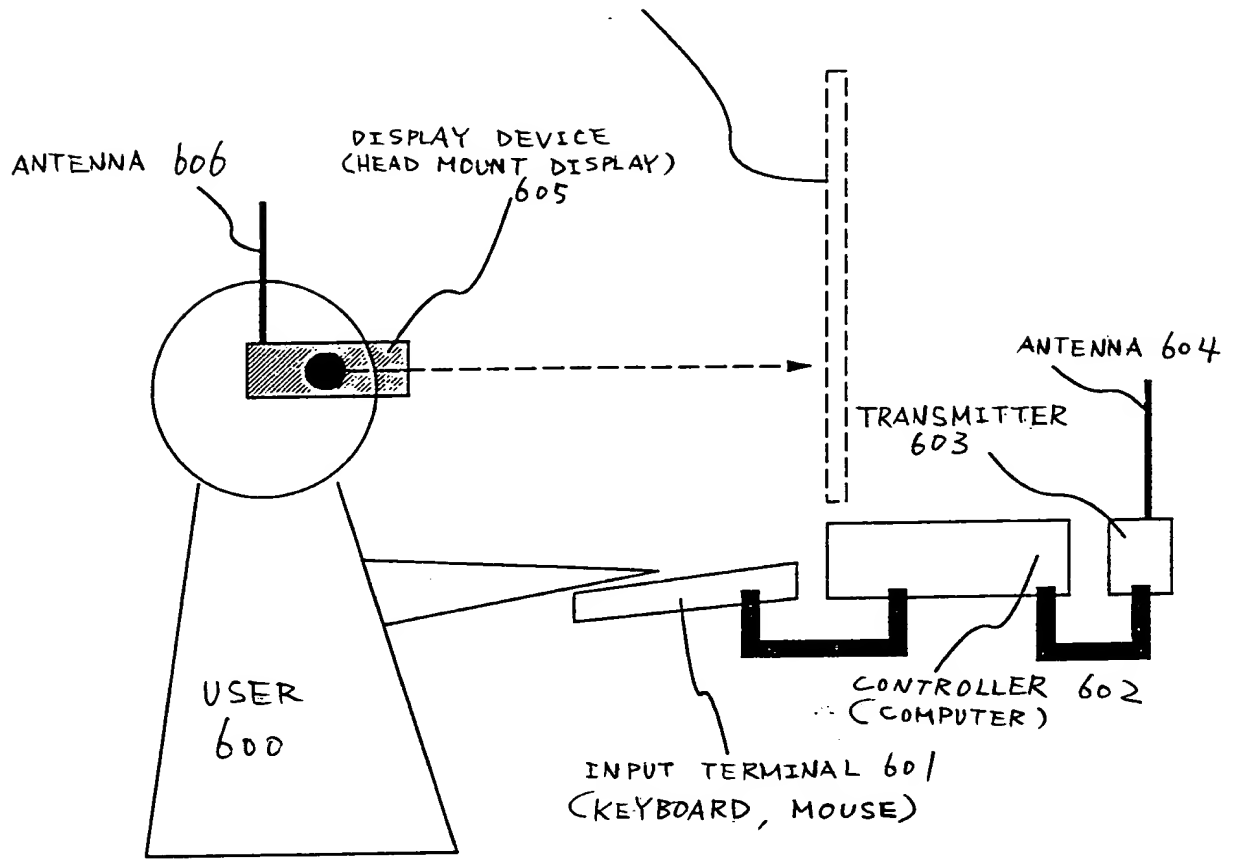


Fig. 6

VIRTUAL DISPLAY SCREEN 708  
(DISPLAY SCREEN FOR TWO-DIMENSIONAL OR  
THREE-DIMENSIONAL IMAGES)

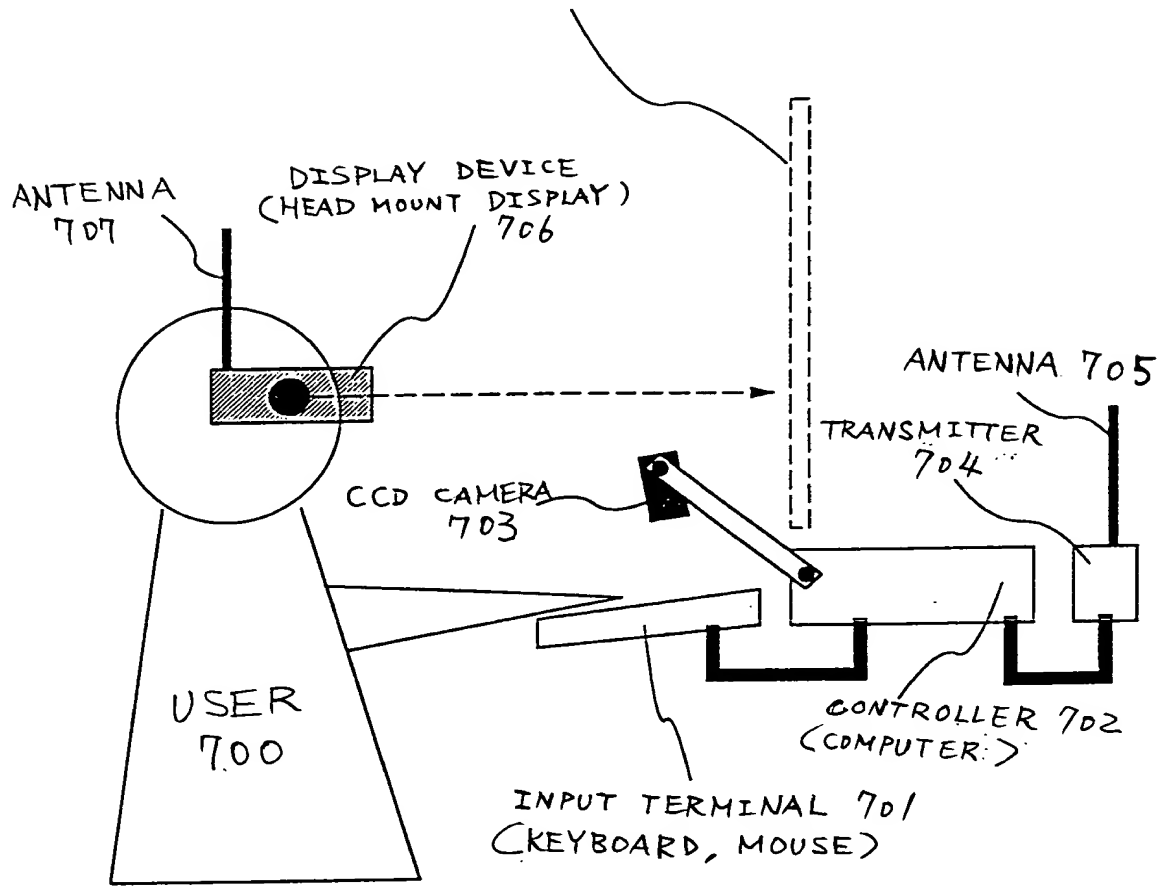


Fig. 7

093505-03260

VIRTUAL  
DISPLAY  
SCREEN  
801

WINDOW  
804

WINDOW 802

WINDOW 803

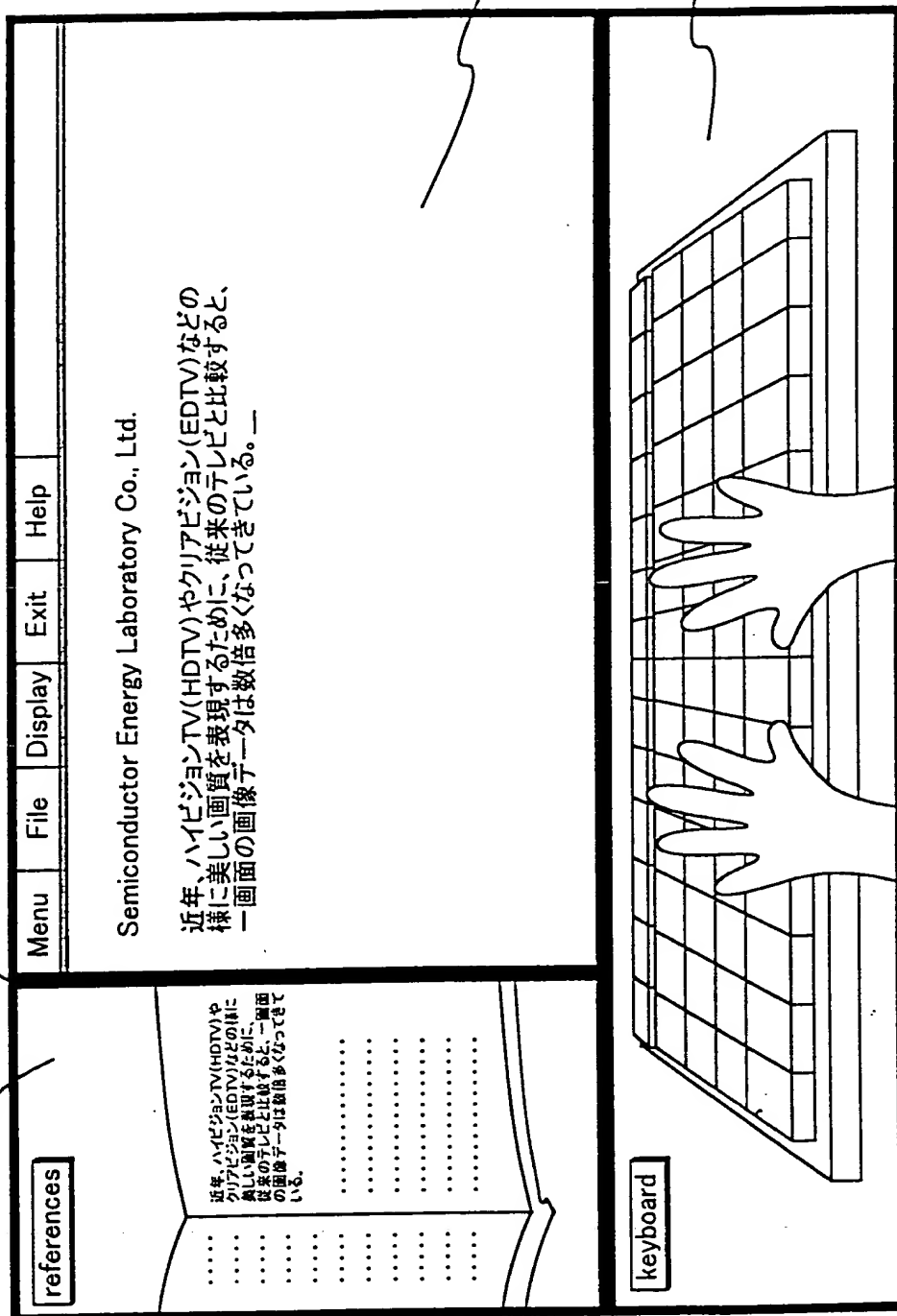


Fig. 8



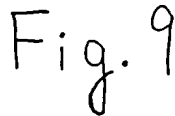
[illegible]

Fig. 9

VIRTUAL DISPLAY SCREEN 1010  
 (DISPLAY SCREEN FOR TWO-DIMENSIONAL OR  
 THREE-DIMENSIONAL IMAGES)

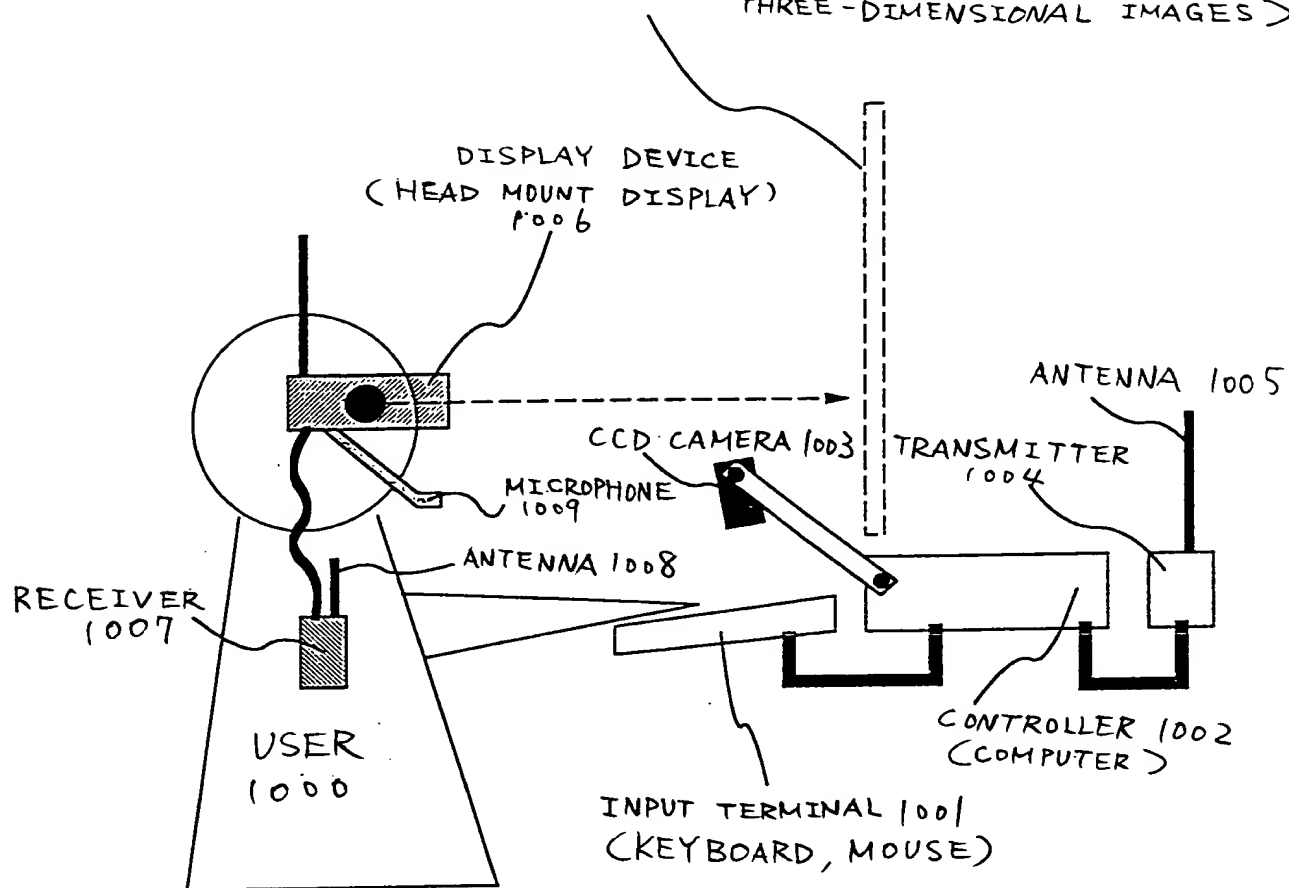


Fig. 10

VIRTUAL DISPLAY SCREEN 1104  
(DISPLAY SCREEN FOR TWO-DIMENSIONAL OR  
THREE-DIMENSIONAL IMAGES)

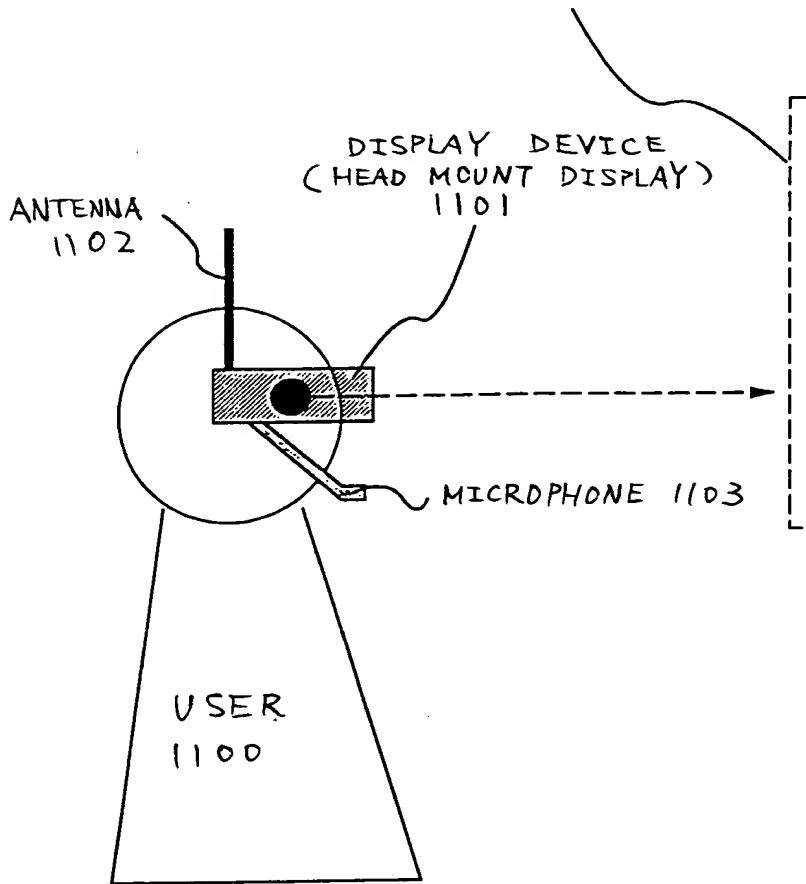


Fig. 11

VIRTUAL DISPLAY SCREEN 1104

WINDOW 1201

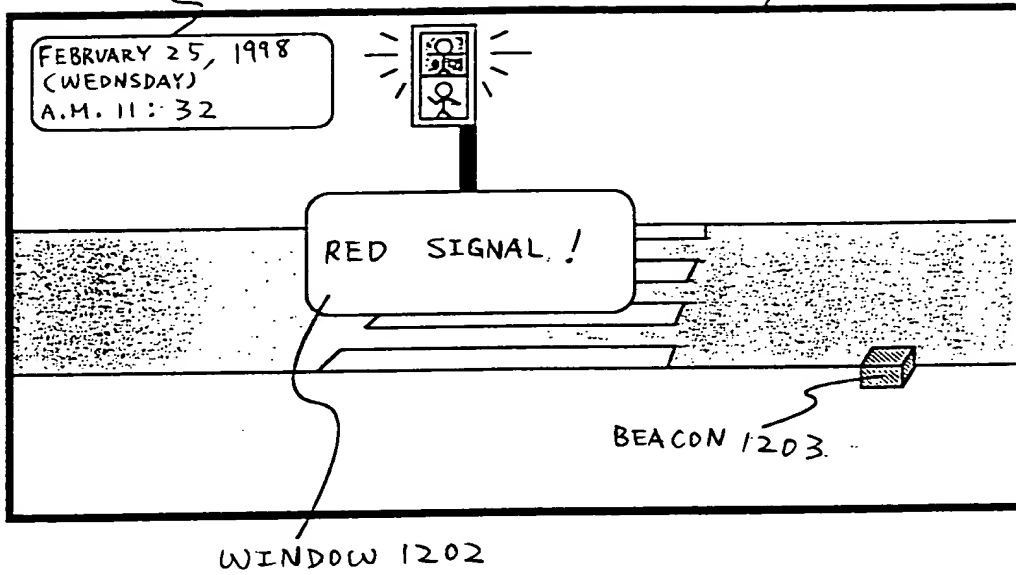
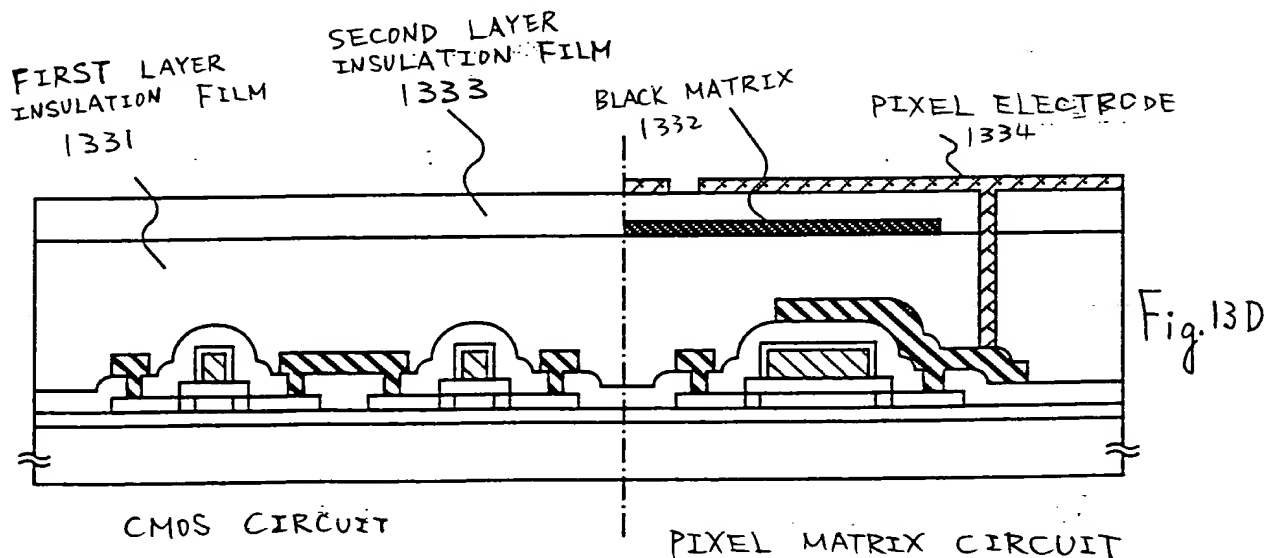
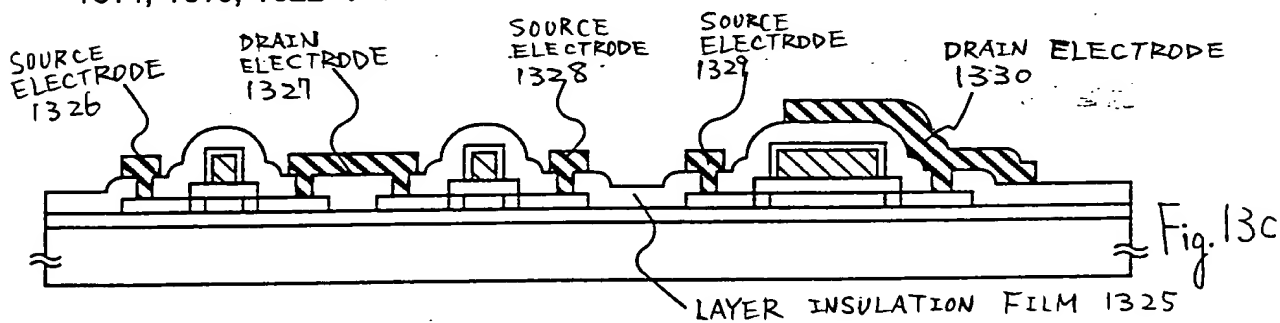
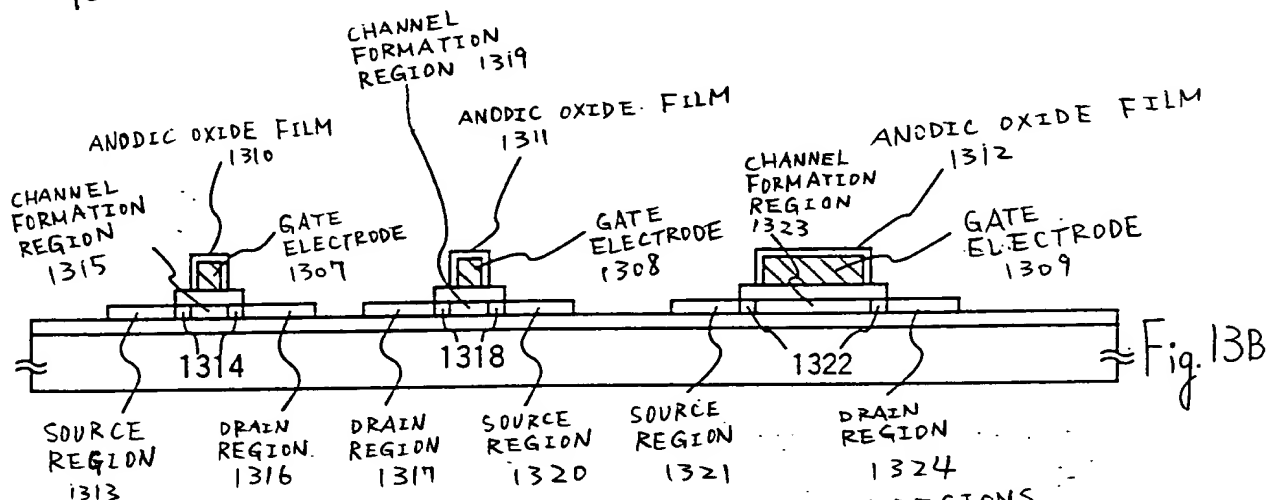
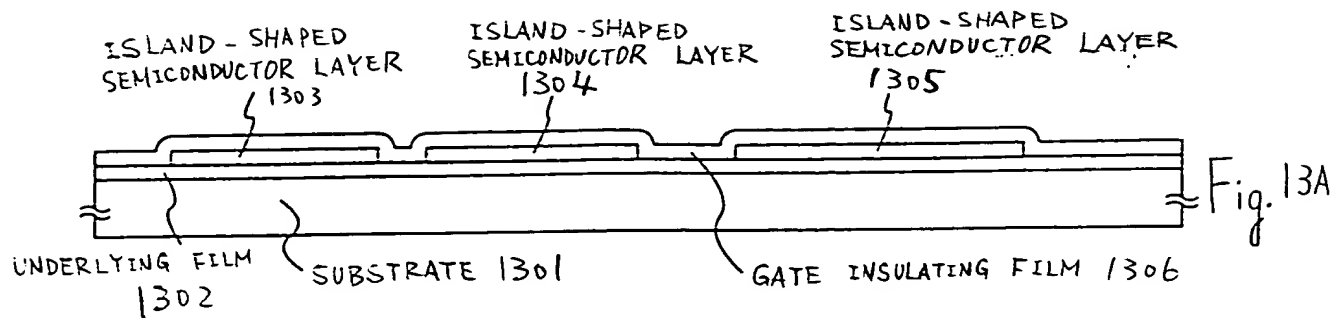
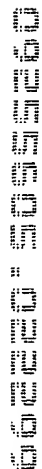


Fig. 12

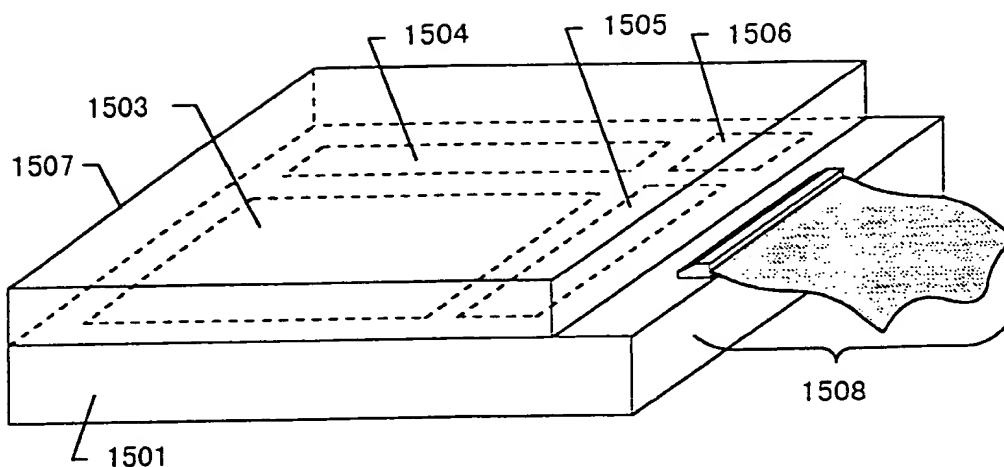
[illegible]



[illegible]

- |      |                      |      |  |
|------|----------------------|------|--|
| 1401 | SUBSTRATE            | 1407 | LDW CONCENTRATION IMPURITY REGION (LDD REGION) |
| 1402 | SILICON OXIDE FILM   | 1408 | CHANNEL FORMATION REGION                       |
| 1403 | GATE ELECTRODE       | 1409 | CHANNEL PROTECTION FILM                        |
| 1404 | GATE INSULATION FILM | 1410 | LAYER INSULATION FILM                          |
| 1405 | SOURCE REGION        | 1411 | SOURCE ELECTRODE                               |
| 1406 | DRAIN REGION         | 1412 | DRAIN ELECTRODE                                |

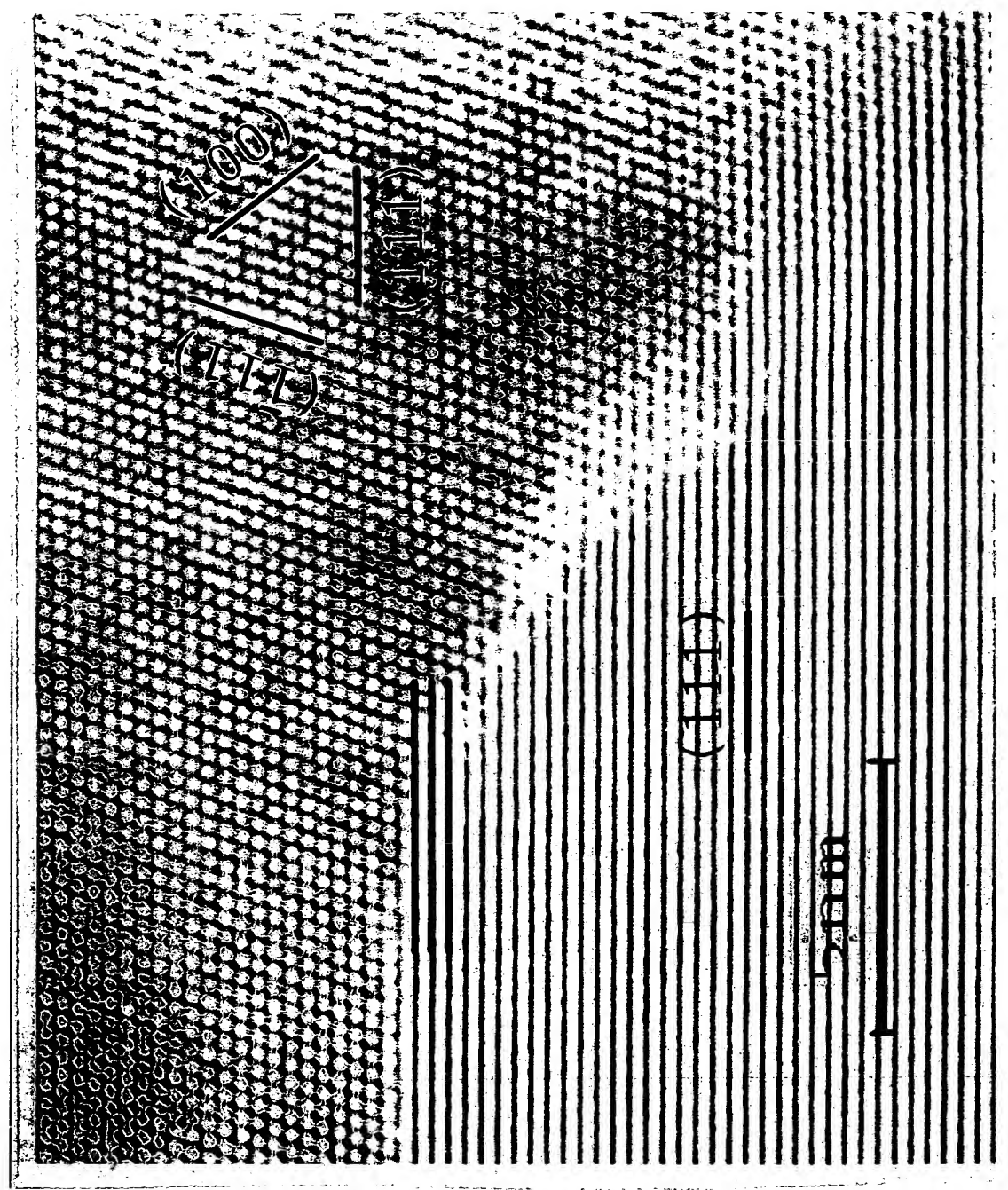
Fig. 15



1501 INSULATING SUBSTRATE	1505 SOURCE-SIDE DRIVING CIRCUIT
1503 PIXEL MATRIX CIRCUIT	1506 LOGIC CIRCUIT
1504 GATE-SIDE DRIVING CIRCUIT	1507 COUNTER SUBSTRATE
1508 FPC	

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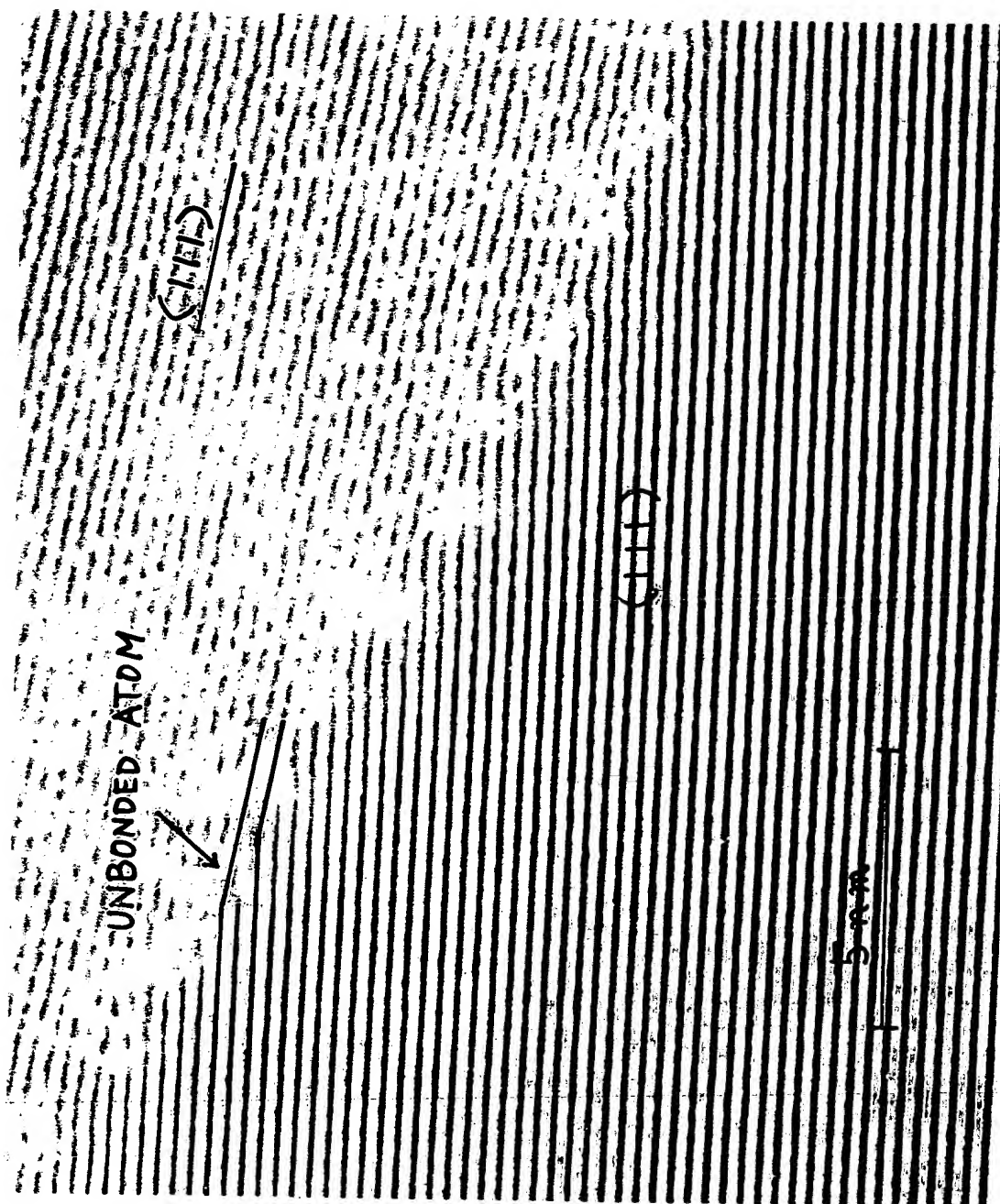
Fig. 16





00000 5055560

Fig. 17



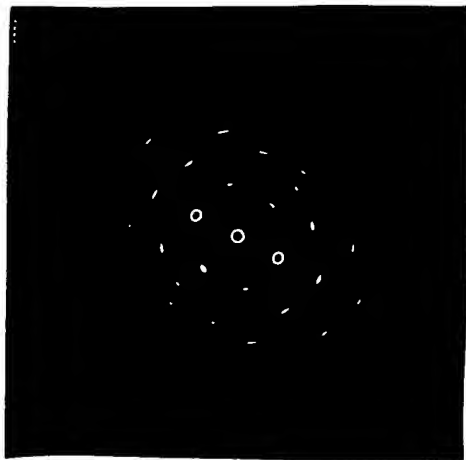


Fig. 18A

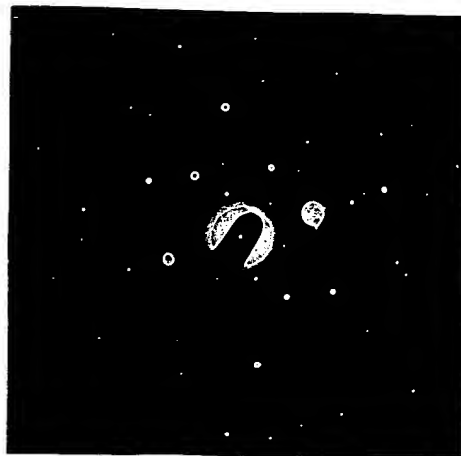


Fig. 18B

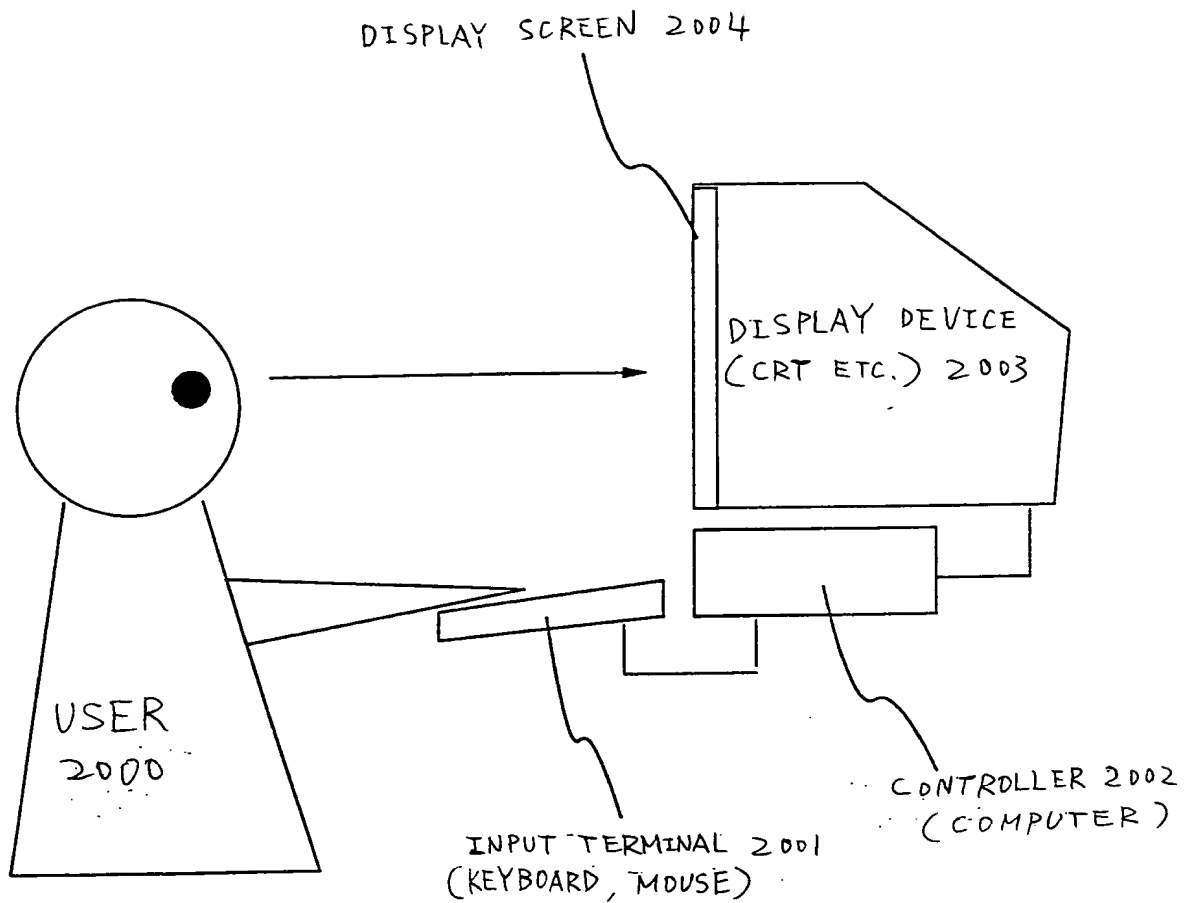
66666 99999

Fig. 19A



Fig. 19B

Fig. 20



SCHEMATIC VIEW OF PRIOR ART INFORMATION  
PROCESSING APPARATUS.